I CLAIM:

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1. A method for fabricating a leadframe structure comprising a chip mount pad and a plurality of lead segments, each having a first end mear said mount pad and a second end remote from said mount pad, comprising the steps of:

forming said structure from a sheet-like starting
 material;

- plating a layer of nickel on said leadframe; selectively masking said second segment ends, thereby leaving said chip pac and said first segment ends exposed;
- selectively plating a layer of palladium on said

 nickel layer on said exposed thip pad and segment ends in a thickness suitable for bonding wire attachment;
 - selectively masking said chip pai and said first segment ends, thereby leaving said second segment ends exposed; and
 - selectively plating a layer of tin onto said nickel layer on said exposed segment ends in a thickness suitable for parts attachment.
- 2. The method according to Claim 1 wherein said plating of said nickel layer and said plating of said selective palladium layer are performed in a first plating system providing for said palladium plating a wheel with apertures defining said selective locations.
- 3. The method according to Claim 1 wherein said plating of said tin layer is performed in a second plating system providing photo-imagible or printable plating masks.
 - 4. The method according to Claim 3 wherein said second

plating system provides: coating with a plating resist; photoimaging; developing said resist; 5 plating with tin; stripping said resist; rinsing; and drying. A method for fabricating a leadframe comprising the 10 steps of: stamping from a sheet-like copper or copper alloy starting material a leadframe having a mount pad for an integrated circuit chip and a plurality of lead segments having their first end near said mount pad and their second end remote from said 15 mount pad; in a first plating system, cleaning said leadframe in alkaline soak cleaning and alkaline electrocleaning; activating said leadframe by immersing said 20 leadframe into an acid solution, thereby dissolving any copper oxide; immersing said leadframe into a first electrolytic nickel plating solution and depositing a first layer of nickel onto said copper, thereby fully 25 encasing said copper; immersing said leadframe into a second electrolytic nickel plating solution and depositing a second layer of nickel onto said first nickel layer, thereby adapting said second ends of said lead 30 segments for mechanical bending and solder

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attachment:

- selectively masking said second segment ends thereby leaving, through apertures in said wheel, said chip pad and said first segment ends exposed;
- immersing said leadframe into an electrolytic palladium plating solution and depositing a layer of palladium onto said exposed segment ends in a thickness suitable for bonding wire attachment:
- in a second plating system, selectively masking said chip pad and said first segment ends, thereby leaving said second segment ends exposed, said masking provided by photoresist coating, photoimaging, and resist developing;
- immersing said leadframe into a tin flood cell plating solution and depositing a layer of tin onto said exposed second segment ends in a thickness suitable for parts attachment; and stripping said photoresist, rinsing and drying.
- 20 6. The method according to Claim 5 wherein said first plating system is a wheel-based system, and said second plating system is a flood cell system.
 - 7. The method according to Claim 5 wherein the process steps are executed in sequence without time delays, yet including intermediate rinsing steps.
 - 8. The method according to Claim 5 wherein said acid solution may be sulfuric acid, hydrochloric acid or any other acid.
- 9. The method according to Claim 5 wherein said '

 30. photoimaging of said photoresist uses a wheel with apertures defining the exposed area of said resist.

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